



PATENT
ATTY. DOCKET NO. SAMD/18US3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Strauss et al. Art Unit: 1753
Serial No. : 08/881,948 Examiner: R. McDonald
Filed : June 25, 1997
For : MECHANICALLY JOINED SPUTTERING TARGET AND ADAPTOR
THEREFOR

Assistant Commissioner of Patents
Washington, DC 20231

RESPONSE TO OFFICE ACTION

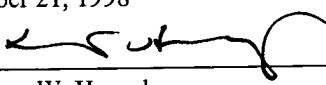
In response to the Examiner's Office Action dated July 10, 1998, please amend the claims as follows:

9. (Twice Amended) A target for installation in a vacuum chamber for processing a substrate by causing sputtering material to be ejected from the target onto said substrate, comprising

a [generally] disk-shaped section having two [generally] planar surfaces and an outer periphery, said [generally] disk-shaped section having at least one radially inward step proximate said outer periphery,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on: October 21, 1998


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